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Applications of Advanced Materials on Optical and Microelectronic Sensing Devices

Guest Editor:

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Message from the Guest Editor

Dear Colleagues,

This Special Issue comprehensively explores the topics covering 1) emerging advanced materials including graphene and carbon nanotubes, quantum dots, metallic conductors, organic polymers, conductive polymers, composites, semiconductors, etc., 2) manufacturing processes such as 2D printing, 3D printing, additive manufacturing, solution processing, electrospinning, etc., and 3) sensing device technologies and applications ranging in healthcare, architecture, environmental and agricultural monitoring, military and aerospace, consumer electronics, and electric vehicles and so on.

Kind regard,

Dr. Pilgyu Kang









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Message from the Editor-in-Chief

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